

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/603,764	KIM ET AL.	
	Examiner	Art Unit	
	Tim Phan	3729	29/852

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
29	852	4/22/2006	TP
/	830	/	/
/	846	/	/
((copper near (layer or sheet)) with (laser or drill\$3)) ...		/	/